## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Jeong-hee Chung et al. Continuation of Serial No.: 10/047,706

Serial No: To Be Assigned Filed: January 15, 2002

Filed: Concurrently Herewith

For: SEMICONDUCTOR CAPACITORS HAVING TANTALUM OXIDE LAYERS

AND METHODS FOR MANUFACTURING THE SAME

Date: March 24, 2004

Mail Stop PATENT APPLICATION Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

Attached is a copy of three form(s) PTO-1449 as filed in parent application serial number 10/047,706, with the application serial number and filing date of the parent application struck through.

A copy of each of the references above has been submitted to, or cited by, the Examiner in the parent application and is not provided herewith.

It is requested that all of these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. §1.56 and Section 609 of the MPEP.

No fee is believed due. However, the Commissioner is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-0220.

Respectfully submitted

Jarett K. Abramson Registration No. 47,376

Customer No. 20792

Myers Bigel Sibley & Sajovec P. O. Box 37428

Raleigh, North Carolina 27627

Telephone: (919) 854-1400 Facsimile: (919) 854-1401

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Clara R. Beard

	Pa	U.S. Department tent and Trademark	Office	· Attorney Docket Number 5649-919DV			Serial No. <del>10/047,706</del>		
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				Filing Date: Jar	nuary 15, 20	002	Group: Not yet known		
			U. S. P.	TENT	DOCUMENTS				
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	3.	Rhee et al. Chemical Vapor Deposition Precursors for (Ba,Sr)TiO3 Films, Laboratory for Advanced Materials Processing (LAMP), Dept. of Chem. Eng., Pohang University of Science and Technology, 233-234 (1999).							
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STATEMENT BY ALL EIGHNI				Group Art Unit	2814			
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Sheet	1	of	1	Attorney Docket Number	5649-919 <b>DV</b>			

U.S. PATENT DOCUMENTS								
Examiner Initials*	Cite No.	U.S. Patent Document		Name of Patentee or Applicant	Date of Publication of	Pages, Columns, Lines, Where Relevant Passages		
		Number	Kind Code (if known)	of Cited Document	Cited Document MM-DD-YYYY	or Relevant Figures Appear		
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS									
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published							
	3	Notice to Submit Response, KR Application No. 10-2001-0003165, August 22, 2002	X						
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